



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: IBARA, Yoshikazu et al.

Group Art Unit: 2823

Serial No.: 09/892,893

Examiner: COLEMAN, William D.

Filed: June 28, 2001

P.T.O. Confirmation No.: 1585

For: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES

AMENDMENT UNDER 37 CFR § 1.111

Commissioner for Patents
Washington, D.C. 20231

December 2, 2002

Sir:

In response to the Office Action dated August 1, 2002, the period for response therefor extended by a Petition for a One-Month Extension of Time, please amend the above-identified application as follows:

IN THE TITLE:

Amend the title as follows:

METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES WITH SILICIDE
FILMS THEREON

47/A
12/21/02
jwm.

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DEC - 5 2002
TECHNOLOGY CENTER 2800